Material	Dual e-Beam	Thermal e-Beam	Sputterer	PLD	Supplied by
Aluminum	X	X	X		**UDNF**
Aluminum Oxide	X	X	X		**UDNF**
Bismuth and Gallium Substituted Thulium Iron Garnet ($Tm_{2.5}Bi_{0.5}Fe_{3.8}Ga_{1.2}O_{12}$)				X	**User**
Bismuth and Gallium Substituted Thulium Iron Garnet (Tm2.7Bi0.3Fe4.5Ga0.5O12)				X	**User**
Boron 10 (B10) >95%			X		**User**
Boron		X			**User**
Boron Carbide			X		**User**
Chromium	X	X	X		**UDNF**
Cobalt	X	X	X		**UDNF**
Cobalt/iron 90/10		X			**UDNF**
Cobalt/Iron/boron 60/20/20 % at 99.95%			X		**UDNF**
Copper	X	X	X		**UDNF**
Gallium Oxide/Bismuth Oxide				X	**User**
Germanium	X	X	X		**Sputterer Target by User**
Gold	X	X			**UDNF**
Iron		X	X		**UDNF**
Mo		X			**User**
MgO		X			**User**
Nickel	X	X	X		**UDNF**

Nickel/Iron 81/19	X	X	X		**UDNF**
Palladium	X	X			**UDNF**
Platinum	X	X	X		**UDNF**
Ruthenium	X	X			**UDNF**
Scandium			X		**User**
Silicon, p-type	X	X			**UDNF**
Silicon Carbide			X		**UDNF**
Silicon Nitride			X		**User**
Silicon monoxide		X			**User**
Silicon Dioxide	X	X	X		**UDNF**
Silver	X	X			**UDNF**
Tantalum	X	X			**UDNF**
Terbium Iron Garnet ($Tb_3Fe_5O_{12}$)				X	**User**
Thulium Iron Garnet ($Tm_3Fe_5O_{12}$)				X	**User**
Tin Oxide			X		**UDNF**
Titanium	X	X	X		**UDNF**
Titanium Oxide	X	X	X		**UDNF**
Tungsten			X		**UDNF**
Tungsten Oxide	X	X			**UDNF**
Vanadium Pentoxide				X	**User**
Vanadium pentoxide/Tungsten Dioxide				X	**User**
Yttrium Iron Oxide (YIG)			X	X	**UDNF**

Last Updated **April 13, 2023**